

<b>Notice of References Cited</b>	Application/Control No. 10/800,196	Applicant(s)/Patent Under Reexamination ABBOTT ET AL.	
	Examiner Heather A. Doty	Art Unit 2813	Page 1 of 1

**U.S. PATENT DOCUMENTS**

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*	B	US-6,133,105	10-2000	Chen et al.	438/296
*	C	US-6,717,205	04-2004	Gratz, Achim	257/316
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	L	US-			
	M	US-			

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**NON-PATENT DOCUMENTS**

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	U	Wolf, S. Silicon Processing for the VLSI Era, vol. 2, Lattice Press, 1990, pp. 557-558.
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\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.